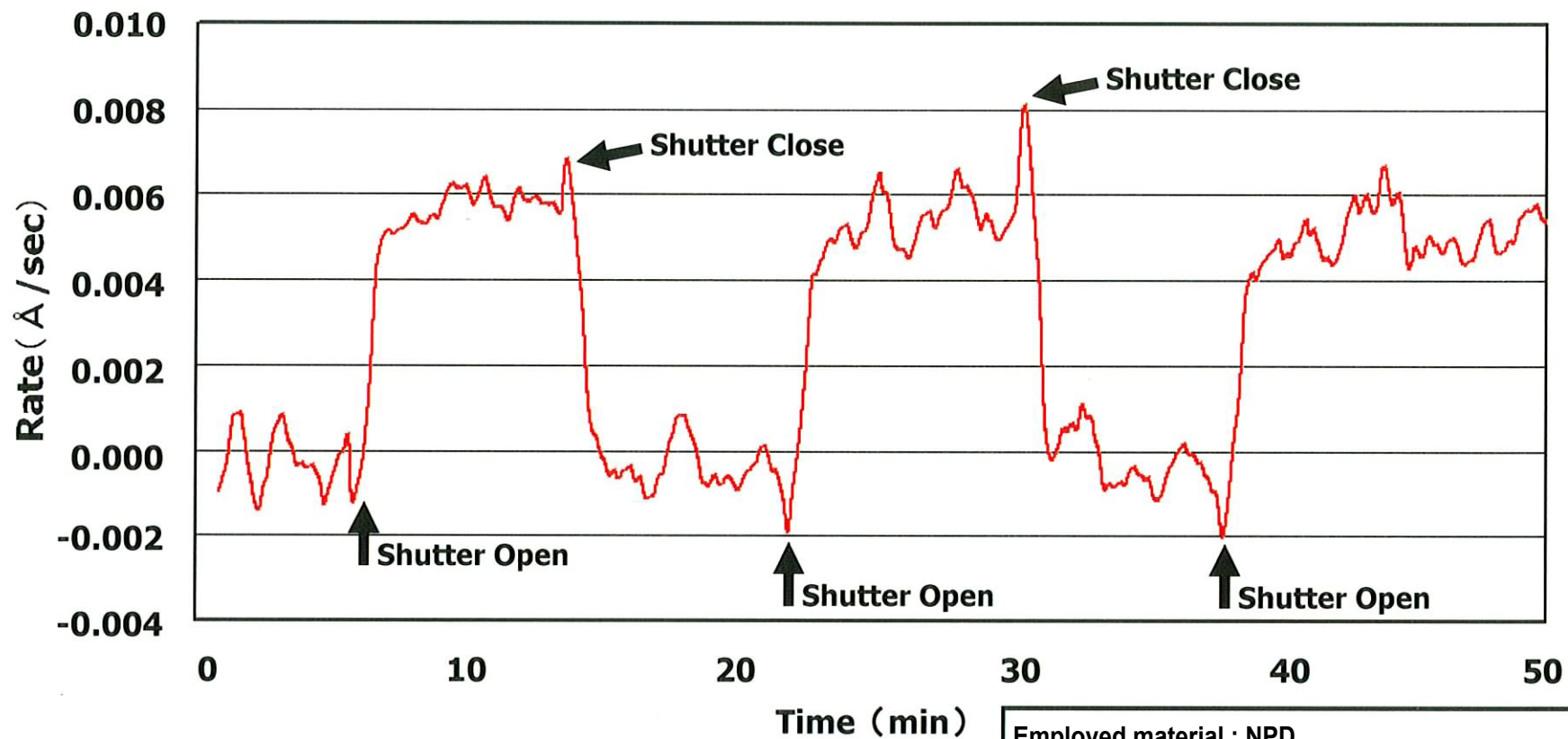


Vapor deposition characteristics with low-rate control



Employed material : NPD
Deposition source : Organic deposition cell (KOD-Cell)
Film thickness meter : CYGNUS made by INFICON